

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Satoshi Murakami, et al.)

Serial No: 09/516,028

Filed:

March 1, 2000

Art Unit: 2815

Examiner: Eugene Lee

For: SEMICONDUCTOR DEVICE

AND METHOD OF

MANUFACTURING THE SAME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450. Alexandria, VA 22313-1450 on Signature Date __

February 3, 2004

AMENDMENT E - AFTER FINAL

Dear Sir:

In response to the Office Action dated December 3, 2003, please amend the above-identified application as follows.